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PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

July 1, 2008

Applicants: Takaomi NAKAYAMA et al

For: TREATING SOLUTION FOR SURFACE TREATMENT OF METAL
AND A METHOD FOR SURFACE TREATMENT

Serial No.: 10/537 329 Group: 1793

Confirmation No.: 8404

Filed: December 2, 2005 Examiner: Zheng

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Atty. Docket No.: 4626.P0002US

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the provisions of Rules 1.97(e)(1) and 1.98, enclosed herewith is a copy of a Japanese Office Action dated April 1, 2008 (and partial translation), JP 08-510505 A and the first page of its corresponding U.S. Patent No. 5,584,946 and JP 2003-155578 A, its English abstract and its JPO Website Computer-Generated Translation. JP 09-503823 and JP 56-103259 in the list of cited documents are not enclosed since their corresponding U.S. Patent No. 5,380,374 and U.S. Patent No. 4,273,592 were filed previously in an IDS.

We are also enclosing a copy of a Chinese Office Action received on April 11, 2008 along with the first page of U.S. Patent No. 5,143,562. WO 95/10641 is not enclosed since its corresponding U.S. Patent No. 5,380,374 was filed previously in an IDS.

Form PTO-1449 is enclosed along with the references cited thereon. The relevance of these references is explained on

the enclosed office actions. Accordingly, further comment at this point in time should not be necessary.

I hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Further consideration is respectfully solicited.

Respectfully submitted,


Terryence F. Chapman

TFC/smd

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*limited recognition number

Encl: Copy of Japanese Office Action dated April 1, 2008
Copy of Chinese Office Action received April 11, 2008
Form PTO-1449 and references cited thereon
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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 1, 2008.


Terryence F. Chapman

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